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PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Application No.: 08/930,449

Filed: October 7, 1997

Docket No.: JAO 39514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF FORMING CRYSTALLINE FILM AND METHOD OF MANUFACTURING THIN FILM ELECTRONIC DEVICE

SUPPLEMENTAL PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows.

IN THE SPECIFICATION:

A Substitute Specification was filed on September 30, 1997. Please amend the Substitute Specification as follows:

Page 1, line 37, change "10 cm⁻²·V⁻¹·S⁻¹" to 100 cm⁻²·V⁻¹·S⁻¹" to --10 cm²·V⁻¹·S⁻¹ to 100 cm²·V⁻¹·S⁻¹--.

Page 2, line 5-6, change "0.1 cm⁻²·V⁻¹·S⁻¹" to 1 cm⁻²·V⁻¹·S⁻¹" to --0.1 cm²·V⁻¹·S⁻¹ to 1 cm²·V⁻¹·S⁻¹--.

Page 12, line 12, change " $F = \frac{1}{6} CV = \frac{1}{\sqrt{3kTm}}$ " to

B $F = \frac{1}{6} cv = \frac{1}{2} \frac{1}{\sqrt{3kTm}}$